



PATENT
Attorney Docket No. A-69175-1/MSS
Dorsey File No. 463035-650

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Nam P. SUH et al.

Serial No. 10/029,158

Filed: December 21, 2001

For: *Apparatus and Method for Chemical
Mechanical Polishing of Substrates*

Art Unit: 3723

Examiner: RACHUBA, MAURINA T

Confirmation No. 5210

Dated: July 22, 2005

CERTIFICATE OF MAILING

I hereby certify that this document or fee is being deposited with the United States Postal Service as First Class Mail addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 20231 on July 22, 2005.

SIGNED:


Claudia Galik

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF PERIOD FOR RESPONSE

Dear Sir:

Pursuant to 37 C.F.R. § 1.136(a), Applicant hereby petitions for an extension of one (1) month within which to respond to the final Office Action mailed March 22, 2005. The extension fee of \$120.00 is included in the Fee Transmittal Sheet Deposit Account Authorization. Please charge any additional fees or credit any overpayment to our Deposit Account No. 50-2319 (Order No. A-69175-1/MSS (463035-150)).

07/26/2005 EFLORES 00000031 502319 10029158
01 FC:1251 120.00 DA

Date: July 22, 2005

Respectfully submitted,

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